

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants: Wayne G. Renken
Title: Process Condition Sensing Wafer and Data Analysis System
Application No.: Not yet assigned Filing Date: October 14, 2003
Examiner: Not yet assigned Group Art Unit: Not yet assigned
Docket No.: SENS.005US1 Conf. No.: Not yet assigned

Mail Stop Patent Application
Commissioner for Patents
P. O. Box 1450
Alexandria, VA 22313-1450

PRELIMINARY AMENDMENT

Dear Sir:

Please amend the above-identified divisional application with which this Preliminary Amendment is being filed, as follows: